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				Application Number	10/581,497
				Filing Date	June 2, 2006
				First Named Inventor	Babak HEIDARI
				Art Unit	1791
				Examiner Name	Stephen J. SOLLENBERGER
				Attorney Docket Number	02386.0105
Sheet	1	of	1		

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials ¹	Cite No. ¹	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
/DNB II/		US 4,844,947	07/04/1989	Kasner et al.	
/DNB II/		US 6,027,630	02/22/2000	Cohen	
/DNB II/		US 6,284,345	09/04/2001	Ruoff	
/DNB II/		US 7,374,864	05/20/2008	Guo et al.	
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FOREIGN PATENT DOCUMENTS						
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		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
/DNB II/		JP 2000-194142	07-14-2000	Fujitsu Ltd		Abstract

NONPATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation ⁶
/DNB II/		WISSEN et al., "UV CURING OF RESISTS FOR WARM EMBOSsing", Elsevier B.V., Microelectronic Engineering, Vol. 73-74, pp. 184-187, (2004).	
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Examiner Signature	/David Brown II/		Date Considered 04/30/2010

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